



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 20, 2026

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG818694795

Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS

KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

FL D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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LABORATORY GROWN DIAMOND

OVAL BRILLIANT

11.73 X 8.09 X 5.14 MM

3.07 CARATS

D

VVS 2

EXCELLENT

EXCELLENT

NONE

IGI LG818694795

IGI



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July 20, 2026

IGI Report No LG818694795

OVAL BRILLIANT

11.73 X 8.09 X 5.14 MM

Carat Weight

Color Grade

Clarity Grade

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

3.07 CARATS

D

VVS 2

63.5%

59%

Medium To Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG818694795

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